

Serial No.:

Docket No.: 56937-043

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Satoru TOMEKAWA, et al.

Serial No.:

Group Art Unit:

Filed: December 03, 2001

Examiner:

For: CIRCUIT SUBSTRATE AND MANUFACTURING MEHTOD THEREOF



INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

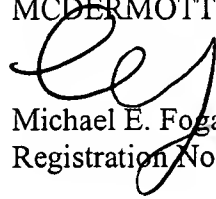
The relevance of each non-English language reference, if any, is discussed in the present specification.

Serial No.

Additionally, attached to JP-2601128 is a corresponding English Abstract of JP-06268345.

Respectfully submitted,

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